

VIA EFS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re:	Patent Application of Masayuki Takashima	: Group Art Unit: 1751 : : :
Conf. No.:	5605	: : :
Appln. No.	10/659,190	: Examiner: Gregory E. Webb : :
Filed:	September 10, 2003	: : :
For:	WASHING LIQUID FOR SEMICONDUCTOR SUBSTRATE AND METHOD OF PRODUCING SEMICONDUCTOR DEVICE	: Attorney Docket : No.: 683261-1US : (F-283-US/JYS) : : :

AMENDMENT AFTER FINAL

This is in response to the Office Action dated June 15, 2006 (Paper No. 20060612), in the above-referenced application. This response is being timely filed by September 15, 2006.

Please amend the application, without prejudice, as follows: